

Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Original) A pellicle for lithography which has at least, a pellicle film for dustproof protection, a pellicle frame to which the pellicle film is adhered, an adhesive layer provided on one end face of the pellicle frame in order to adhere the pellicle film, and a sticking layer formed on another end face of the pellicle frame, wherein the pellicle film is formed by a die coating machine.
2. (Original) The pellicle for lithography according to Claim 1 wherein an area of the pellicle film is 1000 cm² or more, and a distribution of a thickness of the film in plane is within $\pm 10\%$.
3. (Original) The pellicle for lithography according to Claim 1 which is used in a lithography process for manufacture of a liquid-crystal-display panel.
4. (original) The pellicle for lithography according to Claim 2 which is used in a lithography process for manufacture of a liquid-crystal-display panel.
- 5.-21. (Canceled)